



Sheet 1 of 1

Form 1449*

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INFORMATION DISCLOSURE STATEMENT
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Applicant: Leonard Forbes et al.

Filing Date: August 14, 1998

Group: 2818

Viet Q. Nguyen
Primary Examiner

U. S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
VN	4,462,150	07/31/1984	Nishimura, H., et al.	29	576 B	09/16/82
VN	4,768,072	08/30/1988	Seki, Y., et al.	357	29	10/02/86
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FOREIGN PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
VN						

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

**Examiner Initial	Zirinsky, S., et al., "Electrical Resistivity of Amorphous Silicon Resistor Films", <u>Extended Abstracts of the Spring Meeting of the Electrochemical Society</u> , Washington, DC, pp. 147-149, (May 1971)
VN	

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*Substitute Disclosure Statement Form (PTO-1449)

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